



Attorney's Docket No.. 07977-242001 / US3586

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Ohnuma, et al. Art Unit : 1765
Serial No.: 09/050,182 Examiner : R. Kunemund
Filed : March 26, 1998 Confirmation No. : 6531
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE

BOX RCE
Commissioner for Patents
Washington, D.C. 20231

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AMENDMENT

Please amend the above-identified application as follows.

In the Claims:

Please amend the claims as follows.

1. (Amended) A method of manufacturing a semiconductor device including at least a thin film transistor, said method comprising the steps of:

E, forming an amorphous semiconductor film comprising silicon over a substrate having an insulating surface;

providing the amorphous semiconductor film with an element which promotes crystallization of the amorphous semiconductor film;

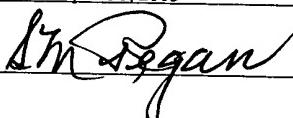
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